

Status of SiW ECAL

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ILD meeting, Seoul, 17 February 2009

- Introduction
- Mechanical
- Integration of DAQ
- Thermal issues
- Reconstruction studies
- Lol section



Advertisement from Roman Poeschl:

A school on calorimetry at the International Linear Collider (ILC) will take place between the 22/4/09 and 26/4/09 at the CCAST in Beijing China. The course of the lectures will cover all aspects of the calorimeters which are currently under design for the detectors to be operated at the ILC. The lectures will be given by international experts who are working actively in the field. The school is intended for students at the master level and is an ideal starting point to get familiar with experimentation at the ILC. Although mainly addressed to students from Mainland China, participants from other countries of the ACFA study are also very welcome and up to 15 students from abroad can be invited

For more information please consult the webpage of the school

<http://www.hep.tsinghua.edu.cn/CalSchool2009>

Introduction

Particle Flow requires E-M calorimeter with

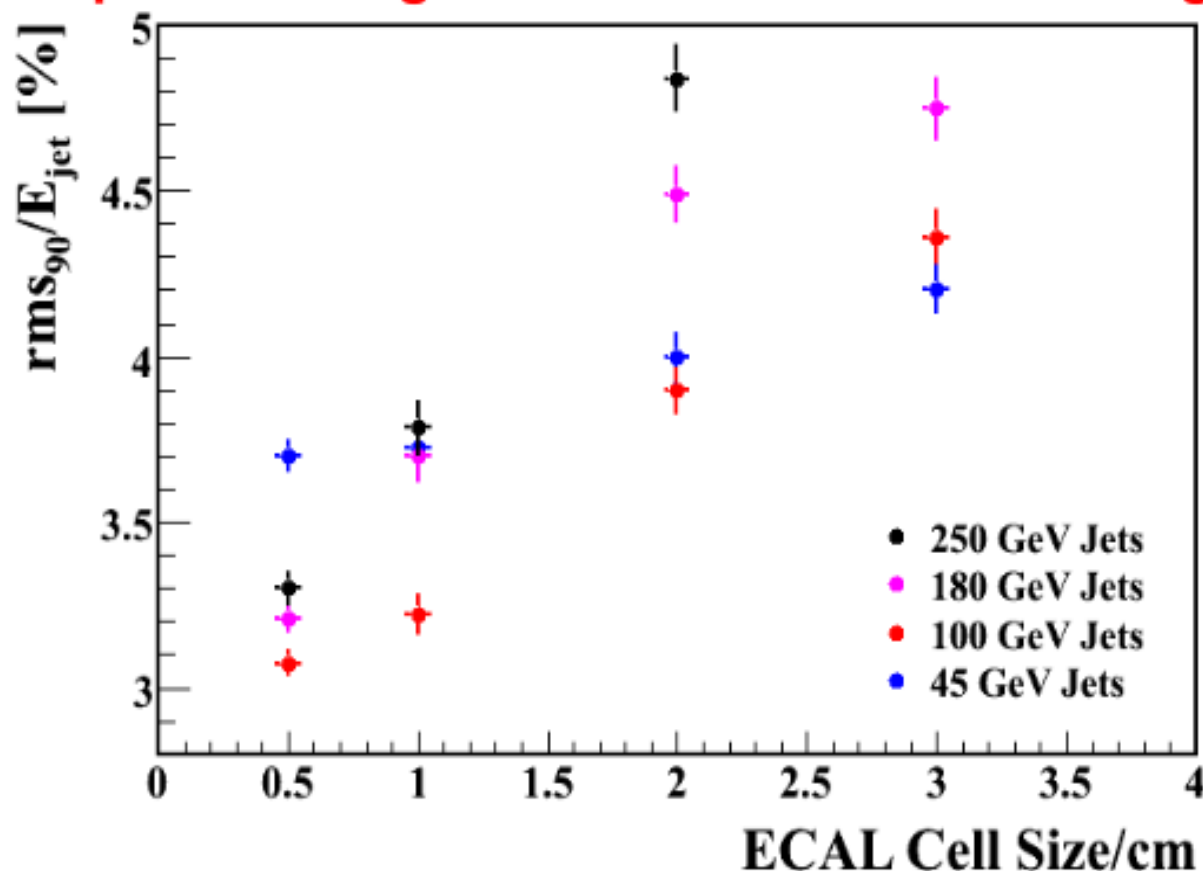
- excellent particle separation: small Moliere radius, high granularity
- good energy resolution

Choose to design sampling calorimeter with

- 30 longitudinal samplings $\sim 24 X_0$
 - 20 layers @ $0.6 X_0$, 9 layers @ $1.2 X_0$
 - Detailed information about longitudinal shower development
- Tungsten passive material
 - Small Moliere radius – 2 photon separation
 - Small X_0 - compact size to fit inside coil
- Silicon active layer, segmented into $5 \times 5 \text{mm}^2$ cells
 - Thin – keep Moliere radius small
 - $\sim 10^8$ channels

R&D within CALICE collaboration

- ★ Start from LDCPrime with 5x5 mm² SiW ECAL pixel size
- ★ Investigate 10x10mm², 20x20mm² and 30x30mm²
 - Note: required changes in PandoraPFA clustering parameters



- ★ Performance is a **strong function** of pixel size
- ★ Probably rules out segmentation of >10x10mm² !!!!

Detector prototypes

Physics prototype exposed to test-beams in last 3 years
~10⁴ channels, 10x10mm² cells

Electrons in range 6-45 GeV:

Energy resolution $\sigma_E/E = (16.6 \pm 0.1)/\sqrt{E} \oplus (1.1 \pm 0.1)$

Non-linearity <~1%

Several issues identified:

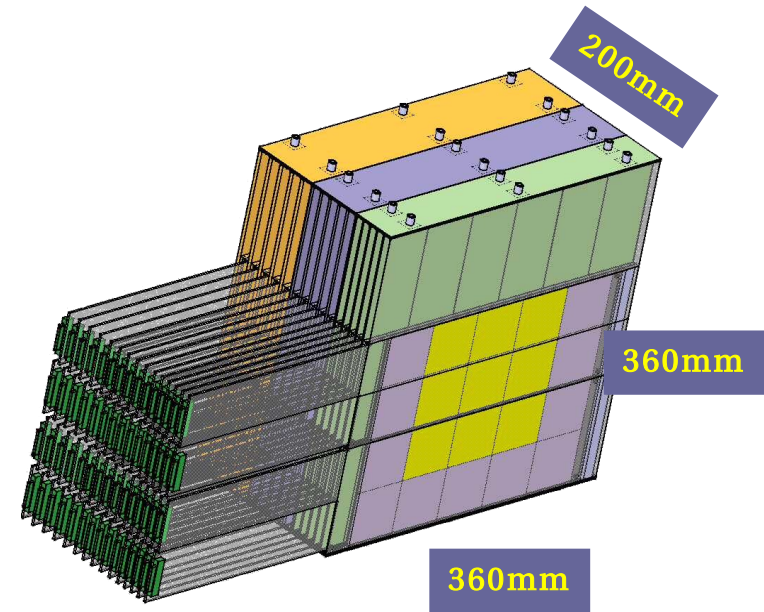
Guard rings at edge of wafers: xtalk wth pixels
Inter-wafer gaps: lost energy

Strategies to improve:

- New Si sensor design to minimise coupling between guard rings & pixels
- Smaller pixels
- Larger wafer to minimise effect of gap effects
- reduction of gaps

Technological prototype planned for future ~ 1 year

- close to ILD ECAL module
- FE electronics inside detector



ILD ECAL

Octagonal barrel + 2 endcaps

Barrel: 8 (ϕ) x 5 (z) identical modules

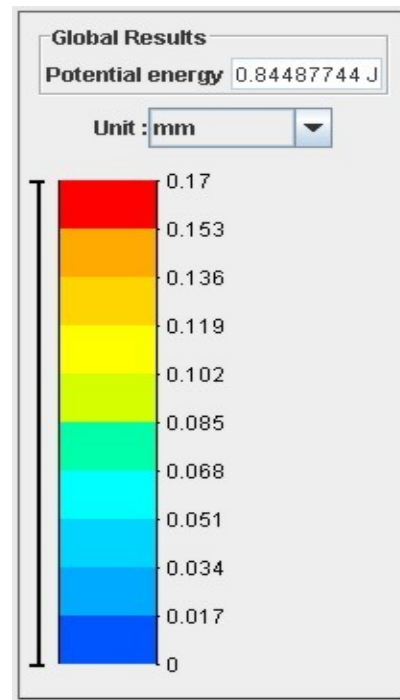
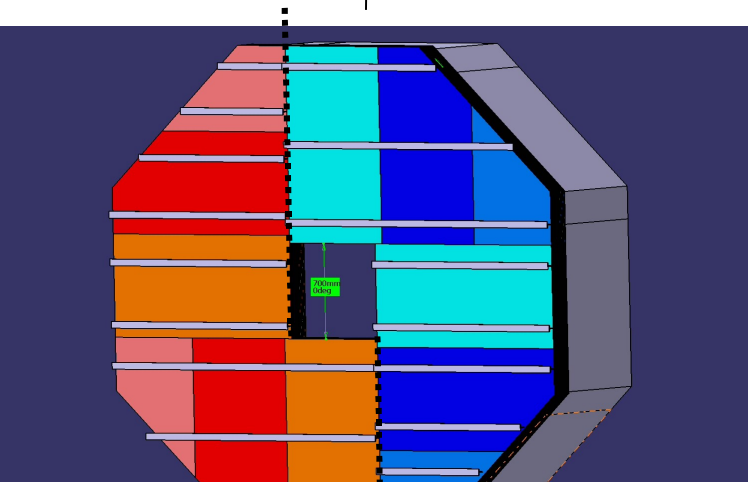
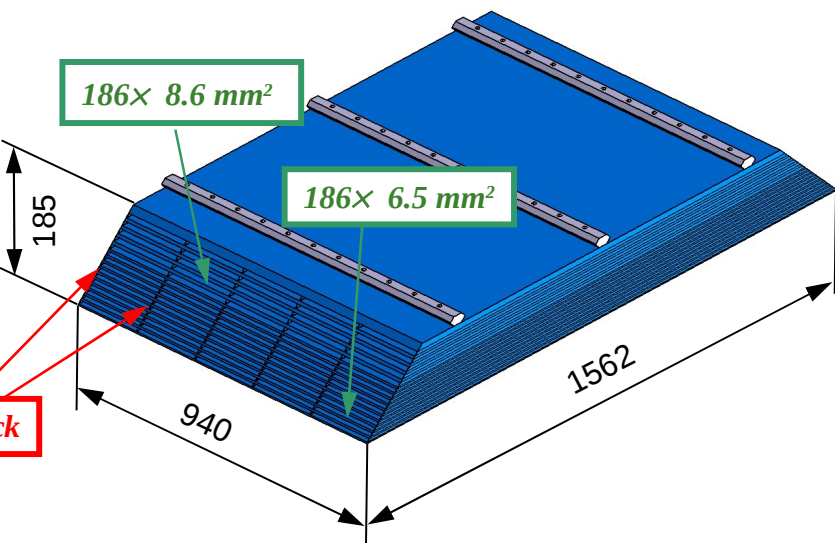
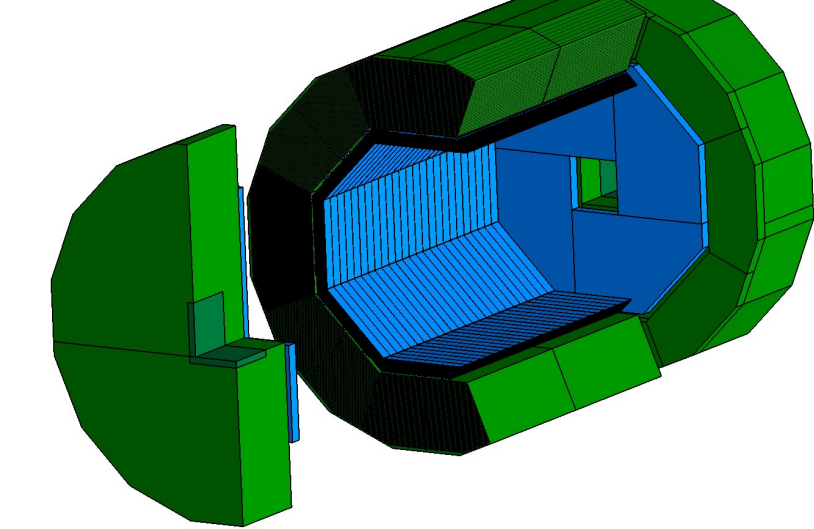
Endcap: 12 modules; 3 types

Gaps between modules non-projective

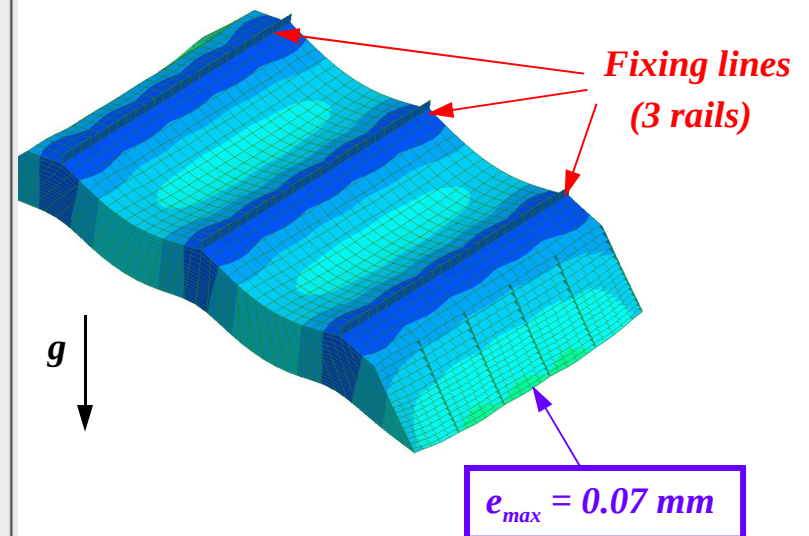
Total mass ~ 80 T (barrel), 32 T (endcaps)

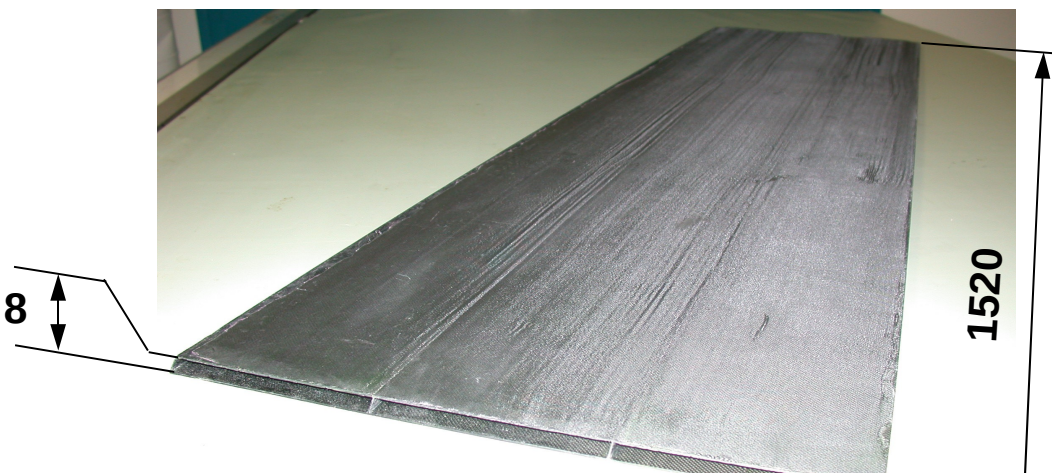
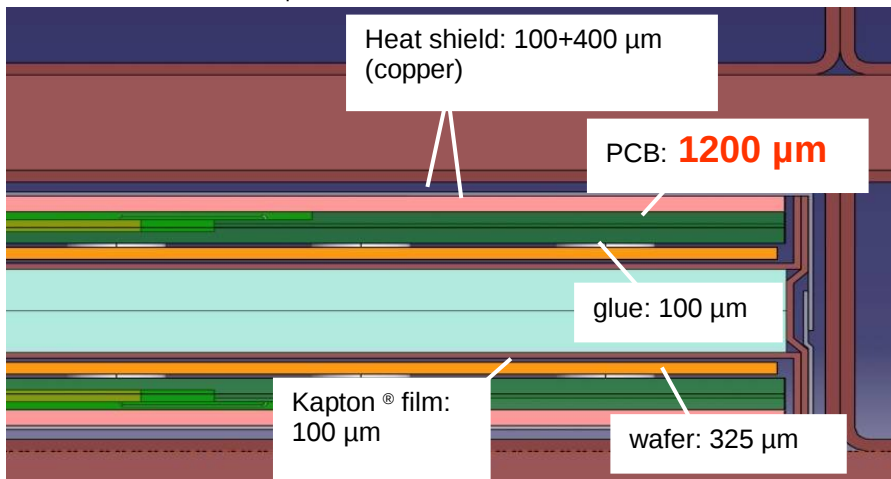
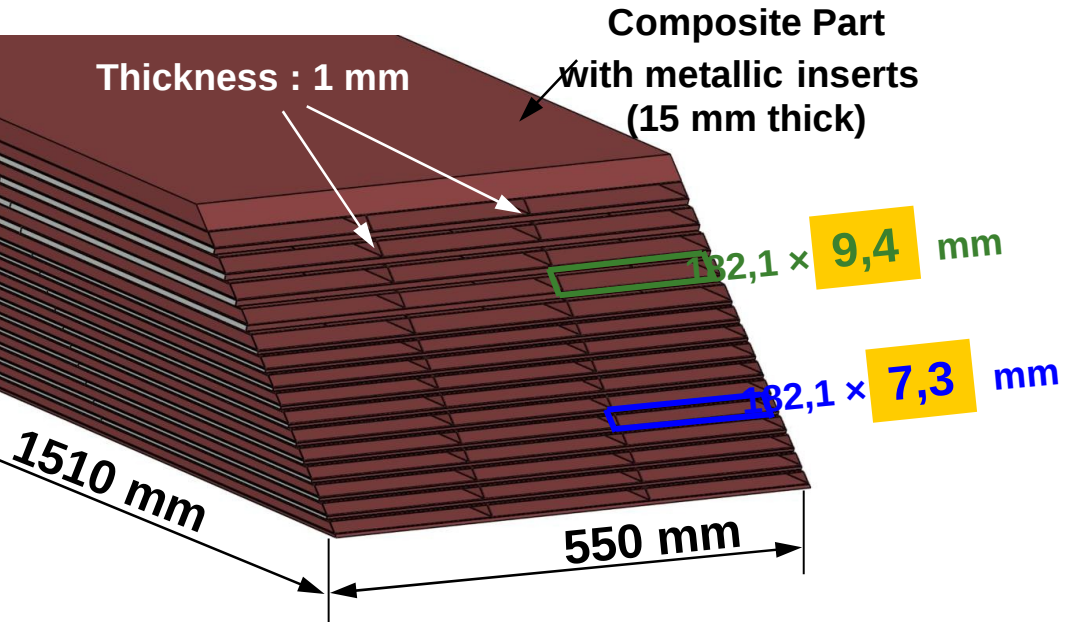
Each module ~ 2-3 T

Modules are attached to inner HCAL face with rails



octagonal design: distortions





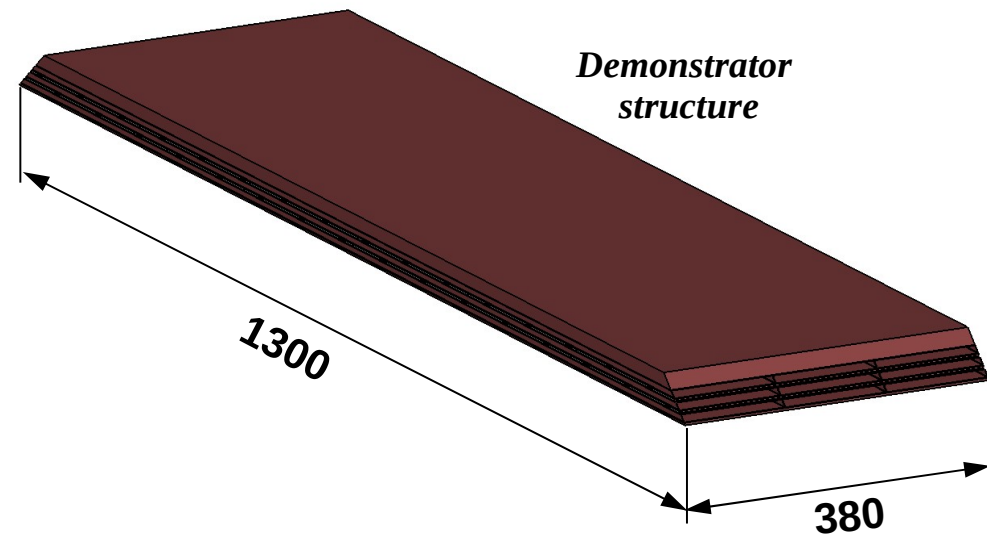
Alveolar structure

Carbon Fibre impregnated with Epoxy
 Layer made in mould
 Layers combined in 2nd step
 Helps quality control for manufacture

½ of tungsten layers integrated in structure

Active detector slabs slide into structure
 Carbon Fibre “H” structure
 Tungsten
 PCB+Silicon sensors+heat shield

3-layer, 1.3m-long **demonstrator module**
 Now ~ ready
 Mechanical & thermal tests



Active layers

Silicon wafers, segmented into square PIN diodes

- total area in ILD $\sim 3000\text{m}^2$
- well-known industrial Si technologies

1st generation (2 manufacturers)

6X6cm² wafers, 10X10mm² cells

Stable operation during 3 years beam tests

Cross-talk between guard ring and cells

Next generation

Hammamatsu

9x9cm² wafers, 5X5mm² cells

- smaller effect of edges

OnSemi

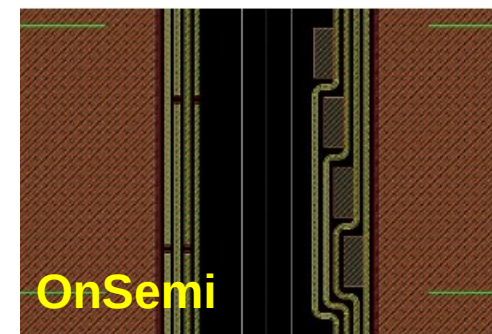
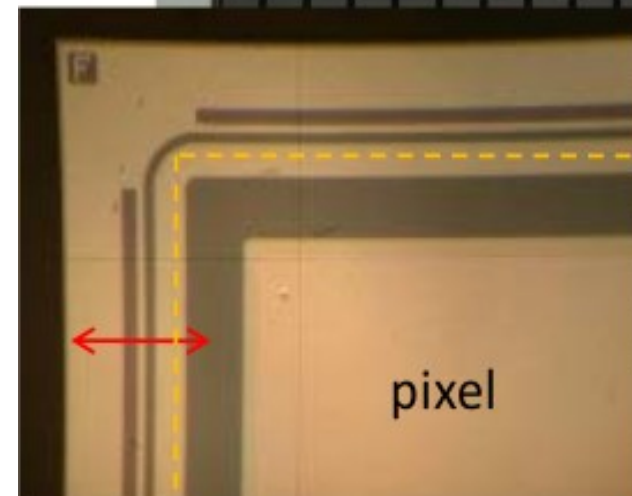
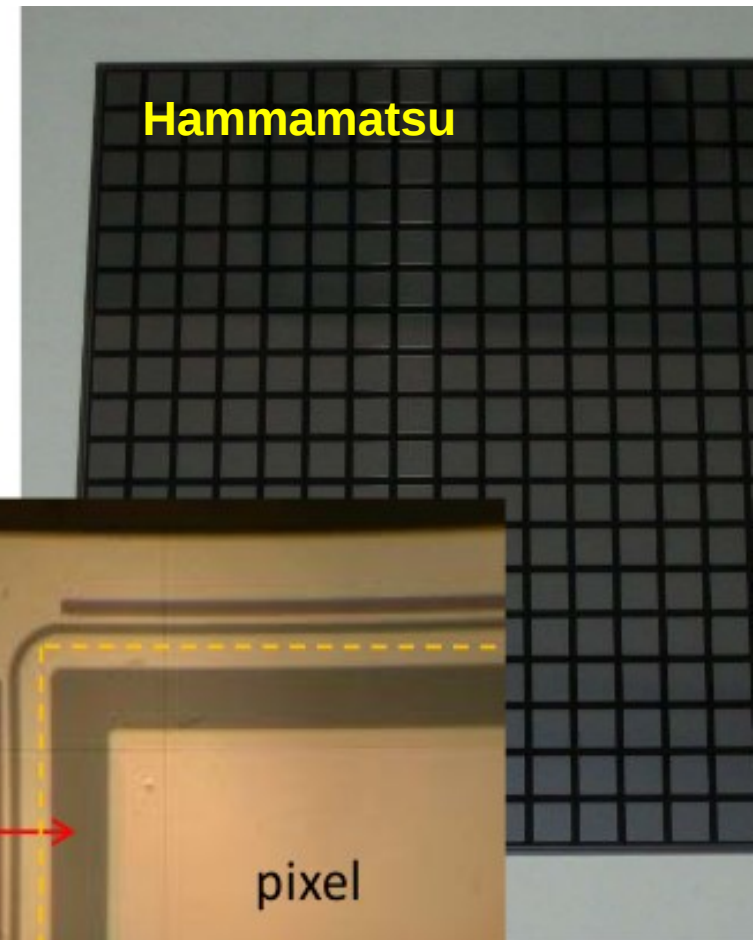
Collaboration to study different designs

e.g. several small test wafers with different guard ring designs

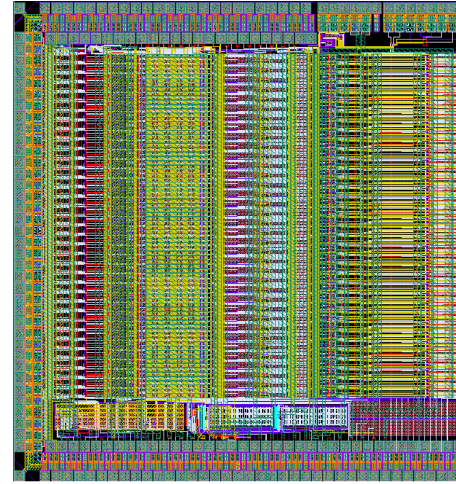
Links with other manufacturers:

Competition is good for us!

Aim for final cost of $\sim 2.5\text{\$}$ per cm².



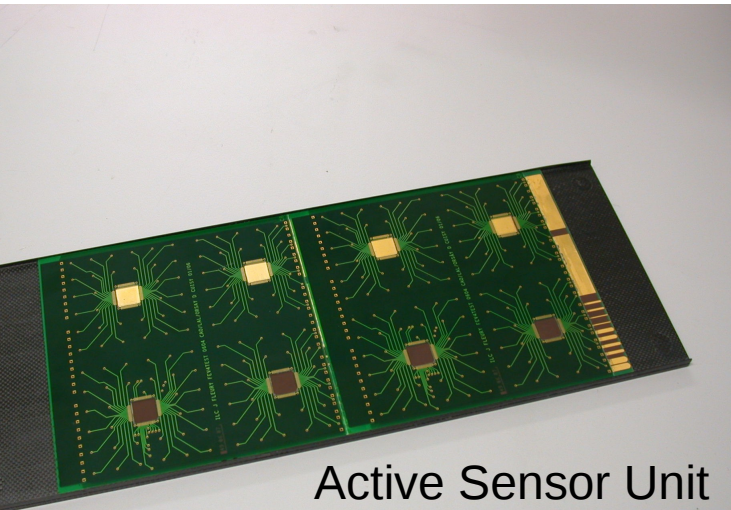
Front-end electronics/DAQ integration



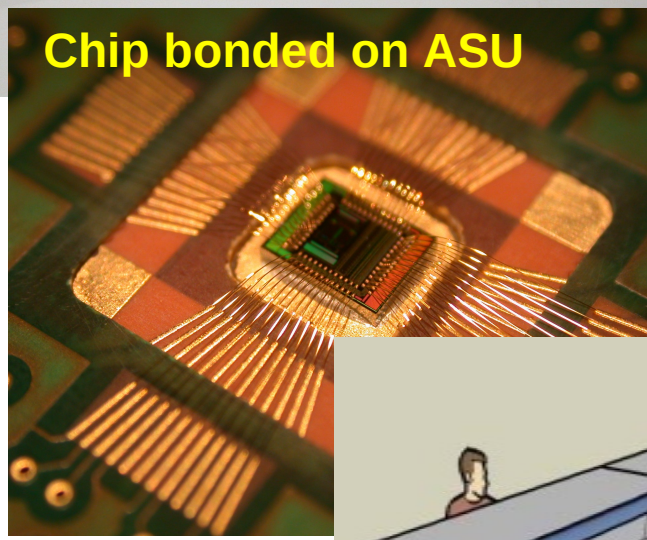
SKIROC

Si sensors mounted on PCB with front-end electronics (SKIROC chip), electrical services, sensors

Several ASU connected into one slab, read out by a single DIF card

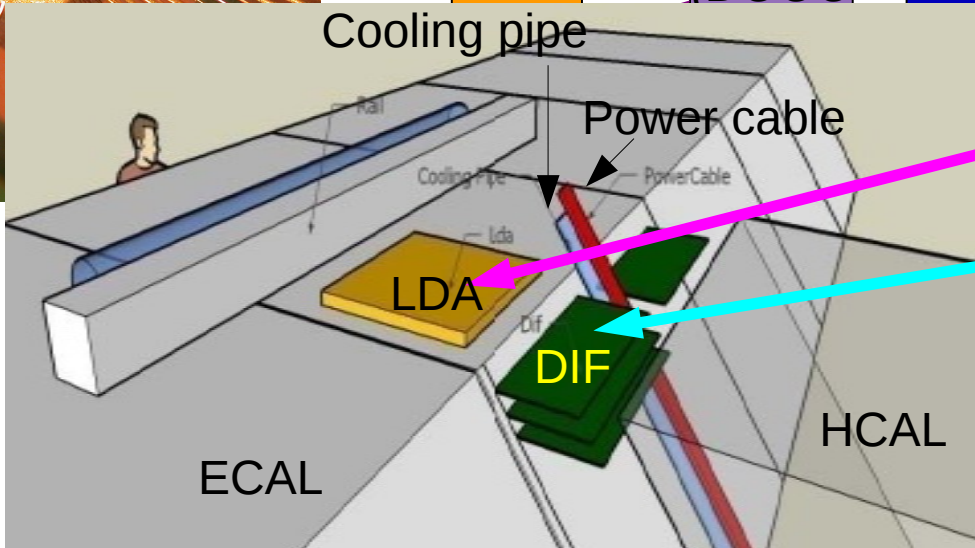
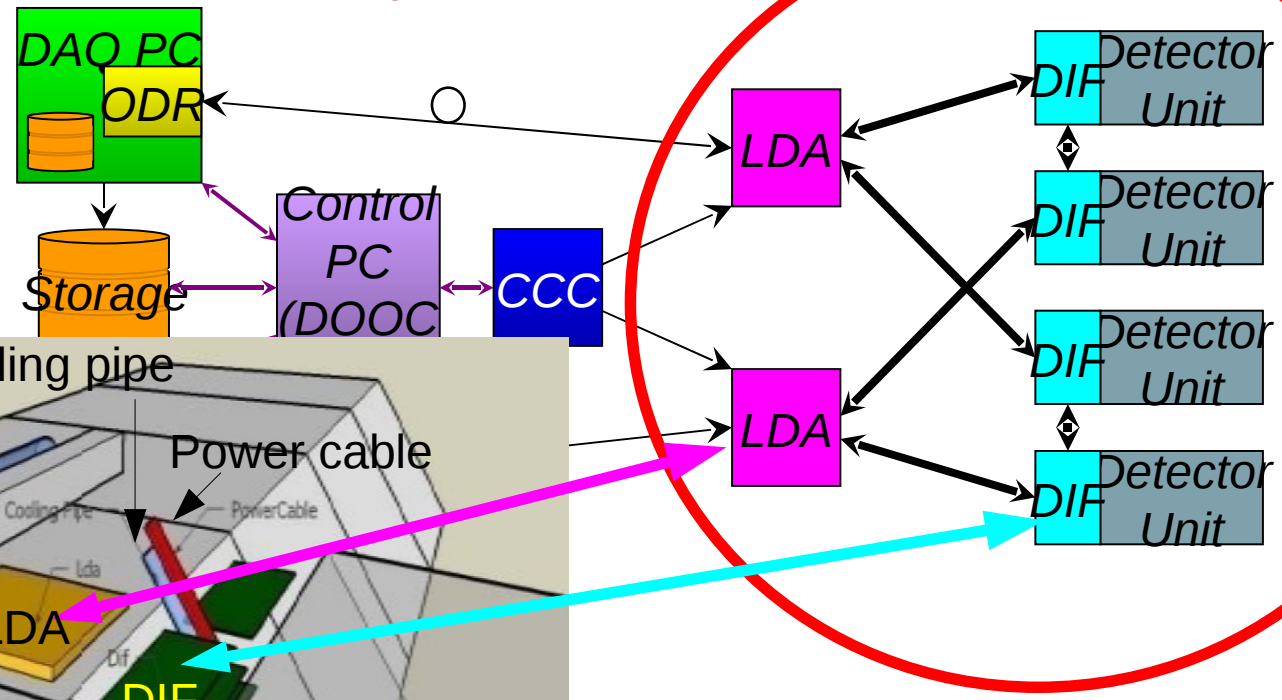


Active Sensor Unit



Chip bonded on ASU

CALICE DAQ architecture



These sit in ECAL/HCAL gap

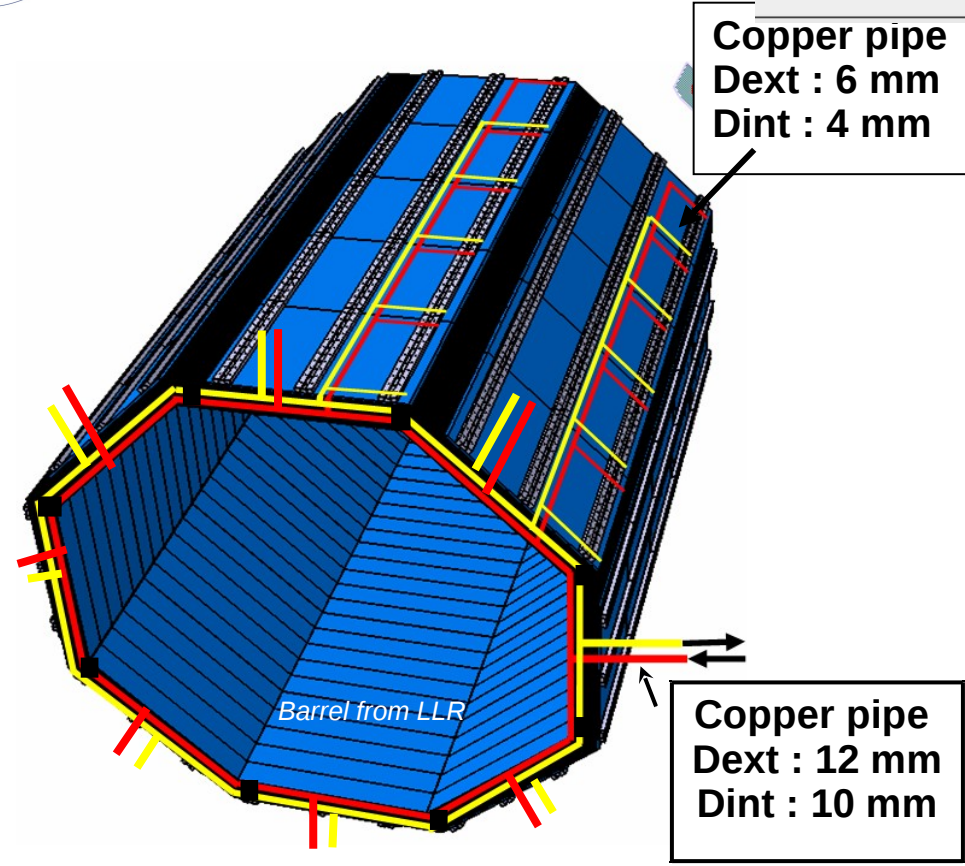
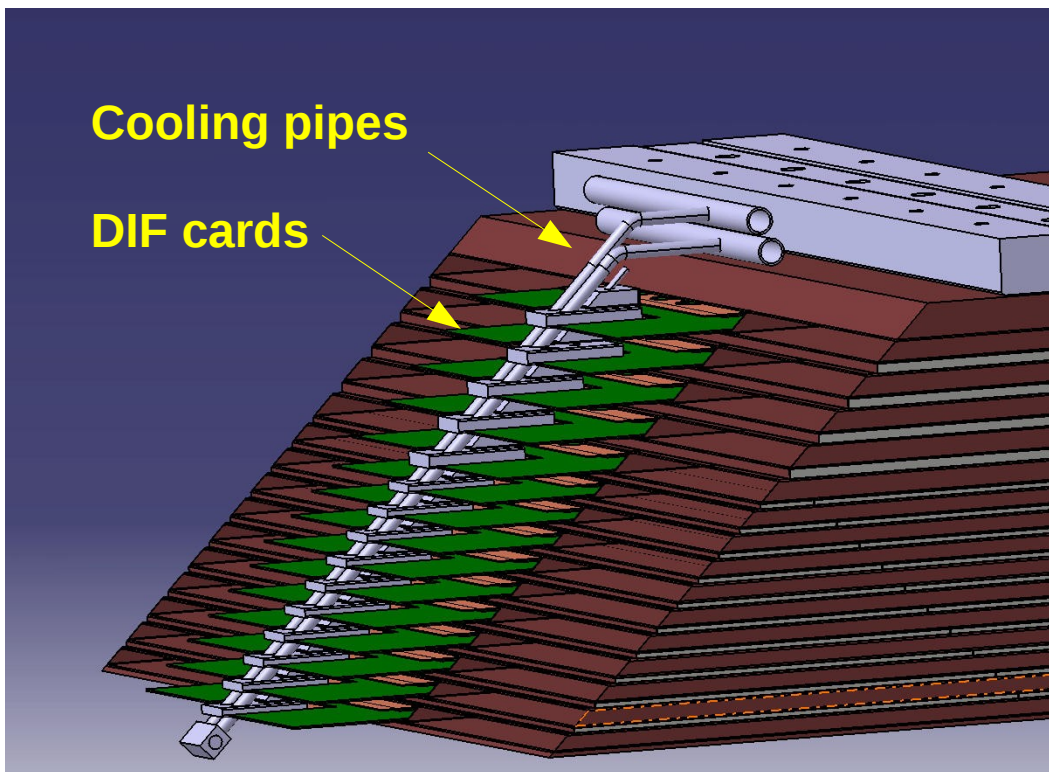
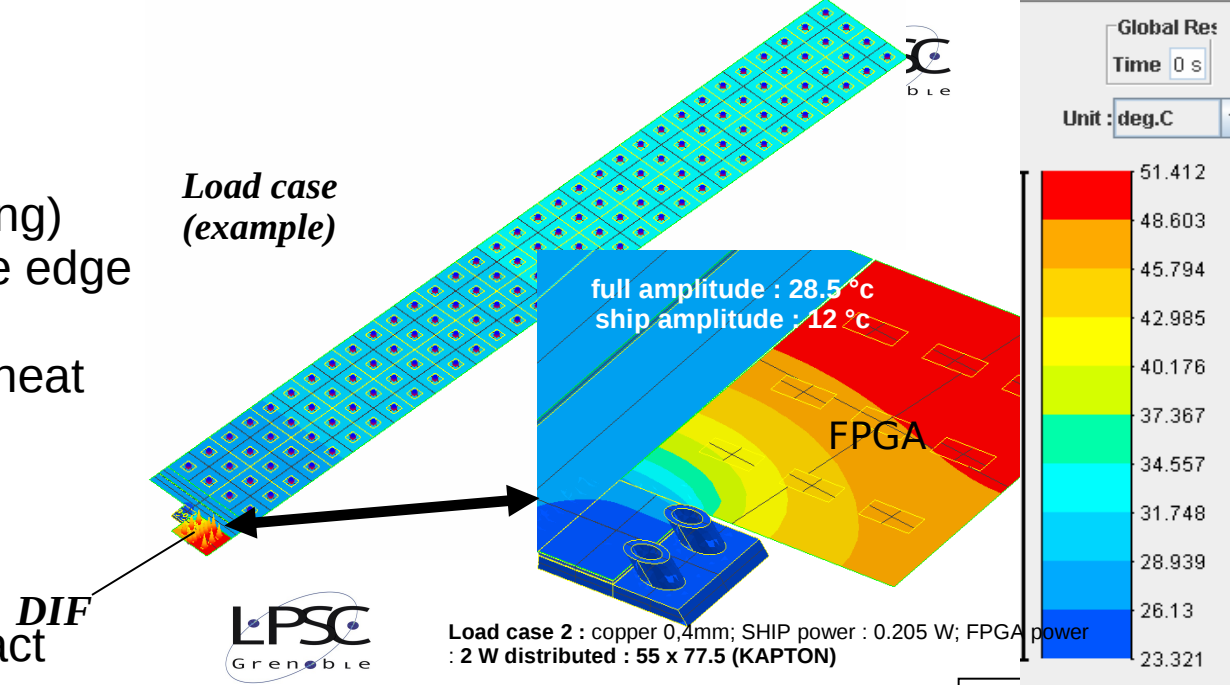
Heat & Cooling

VFE ~ 25 μ W/channel (with power pulsing)
 Cu layer in slab brings heat to module edge

FPGA on DIF card produces additional heat

Total: ~ 3000W for barrel
 ~ 800W per endcap

cooling pipes (in ECAL/HCAL gap) extract heat from module edge
 Go to outside world via barrel/endcap gap



Photon reconstruction

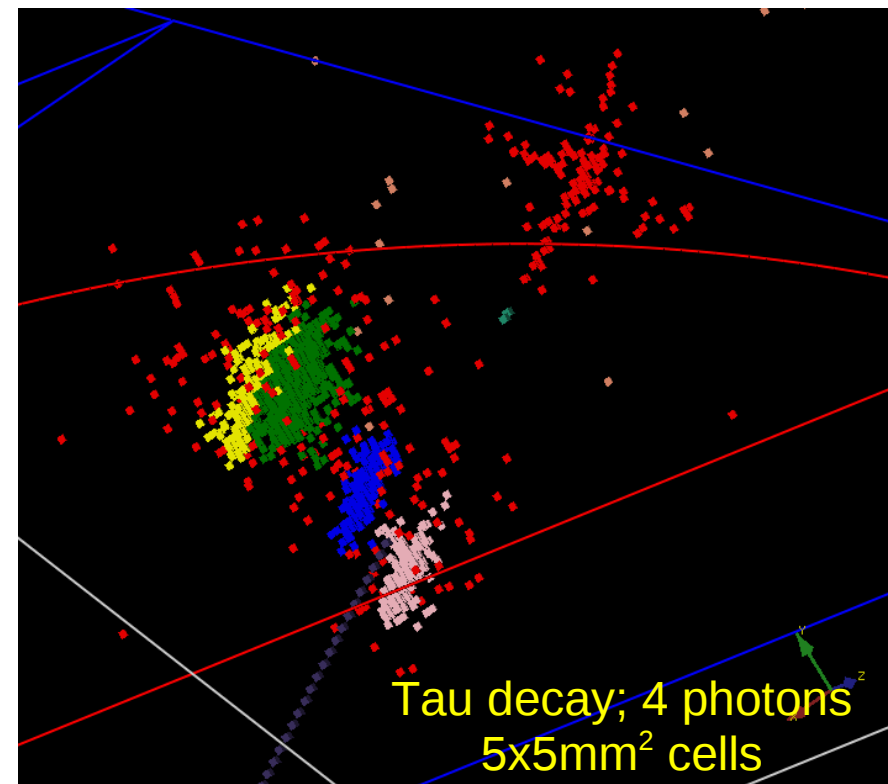
Dedicated photon identification: GARLIC algorithm

- Identify photons & electrons

- Estimate energy

- Distinguish near-by photons

see Marcel's talk (yesterday)



Lol contents

General Calorimeter section

- Introduction

 - Di-jet mass resolution for W/Z separation

 - $dE/E \sim 3\%$

 - PFA drives design

- general mechanical description

 - Different calorimeter options in EM & Had

SiW Ecal section of Lol

- Introduction

PFA requires compact EM cal with high granularity, small Moliere radius
Fine longitudinal and transverse segmentation
Tungsten absorber, Si measurement layers

- Geometry & mechanical design

20 layers * 0.6 X0, 9 layers @ 1.2 X0
5X5mm² cells

Hermeticity

large detector modules to reduce cracks
Non-pointing cracks in octagonal geometry

Assembly and integration of ECAL modules in ILD.

- Active layers

Silicon sensors

3000M² in total, standard production techniques

Silicon producers

Long-term (~3 year) tests of 1st generation sensors from 2 manufacturers
Collaboration with industry to study sensor design improvements
Silicon simulation tools available

Summary

Mechanical structure of ECAL modules well studied,
various prototypes built, under construction

Now have had ~3 years operating 1st generation Si wafers
Si development continuing, with several manufacturers

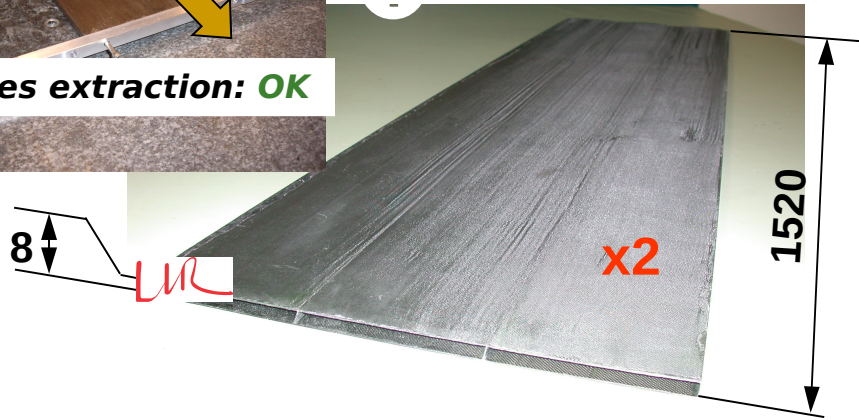
Good idea of DAQ and thermal integration into ILD

Specialised photon reconstruction algorithms under development

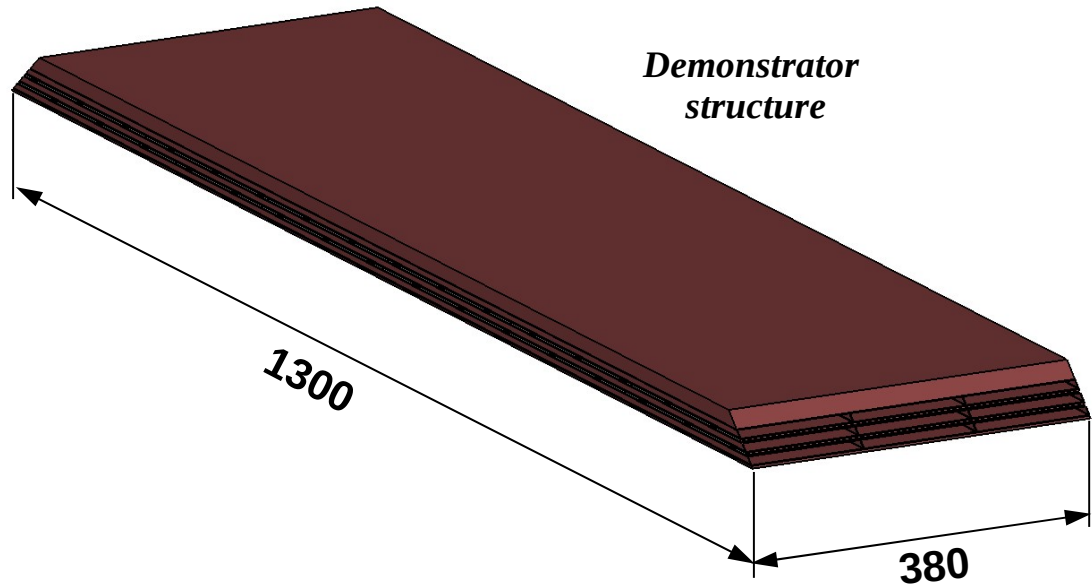
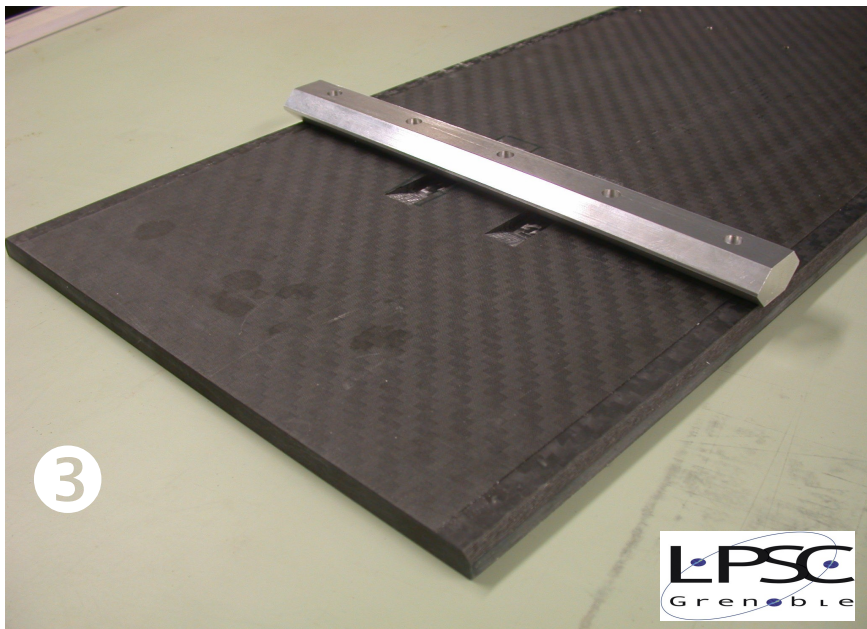
Backup slides



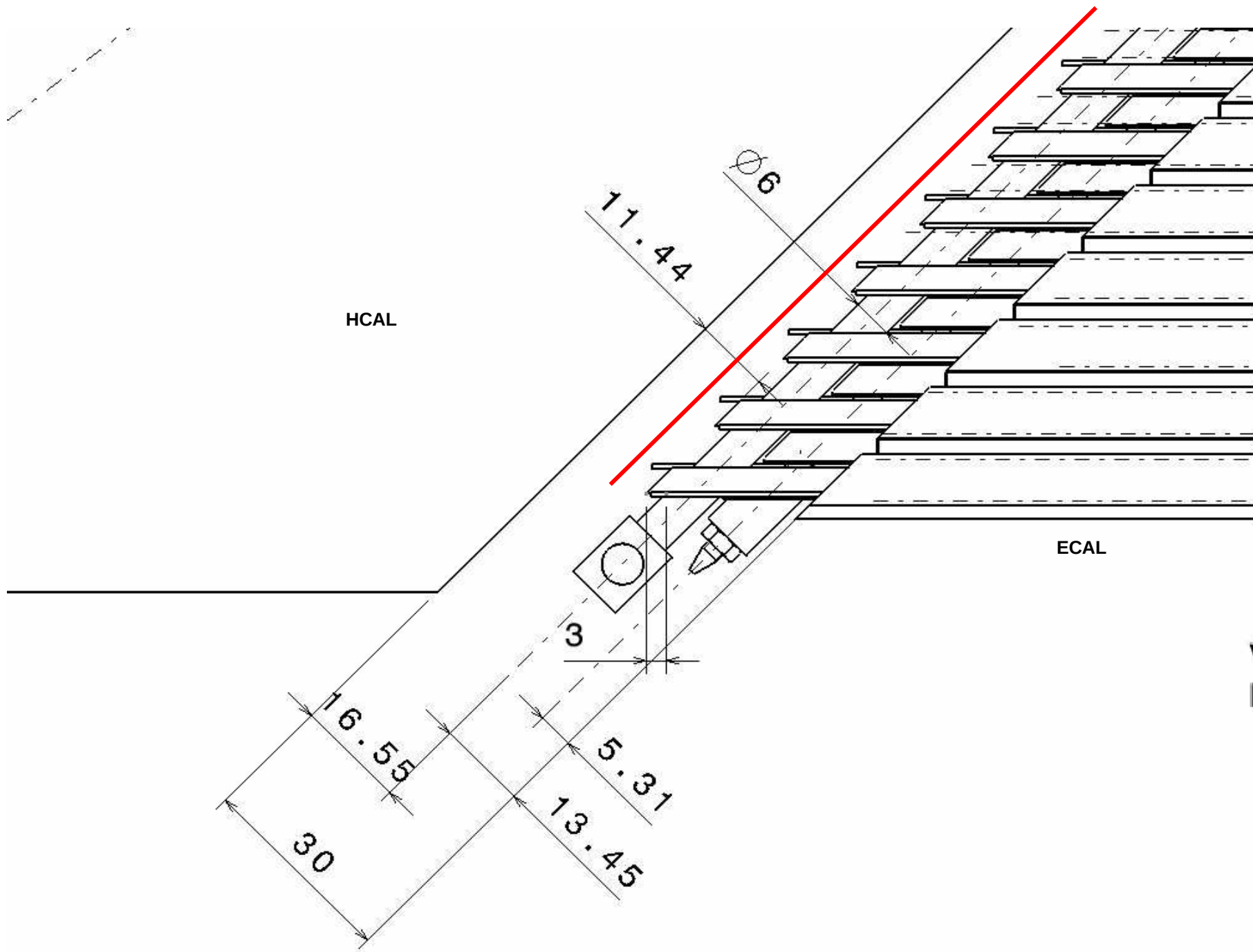
first test of alveolar layer



top composite plate (15mm)



Demonstrator structure

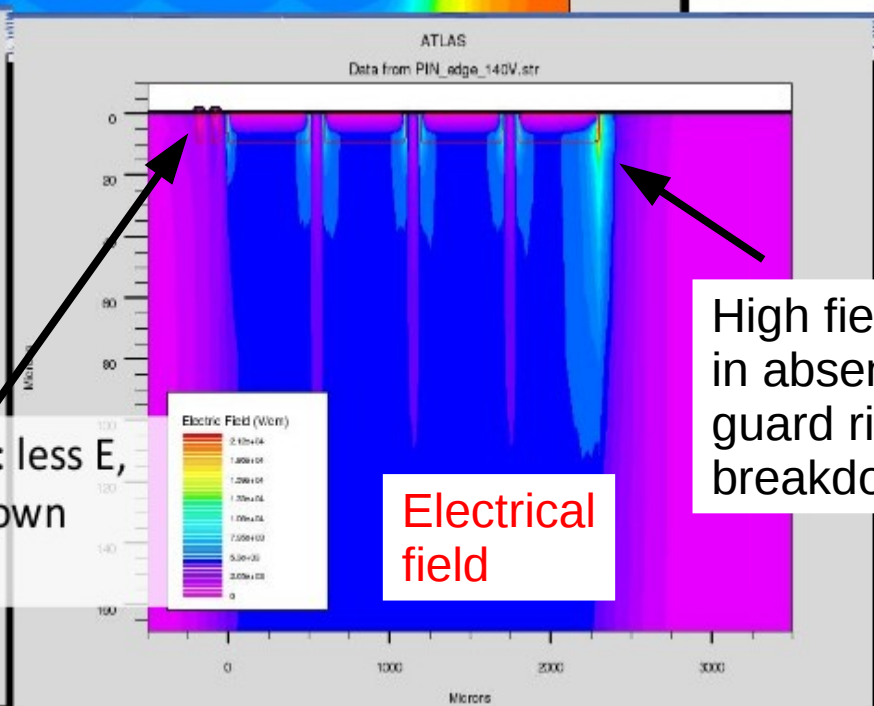
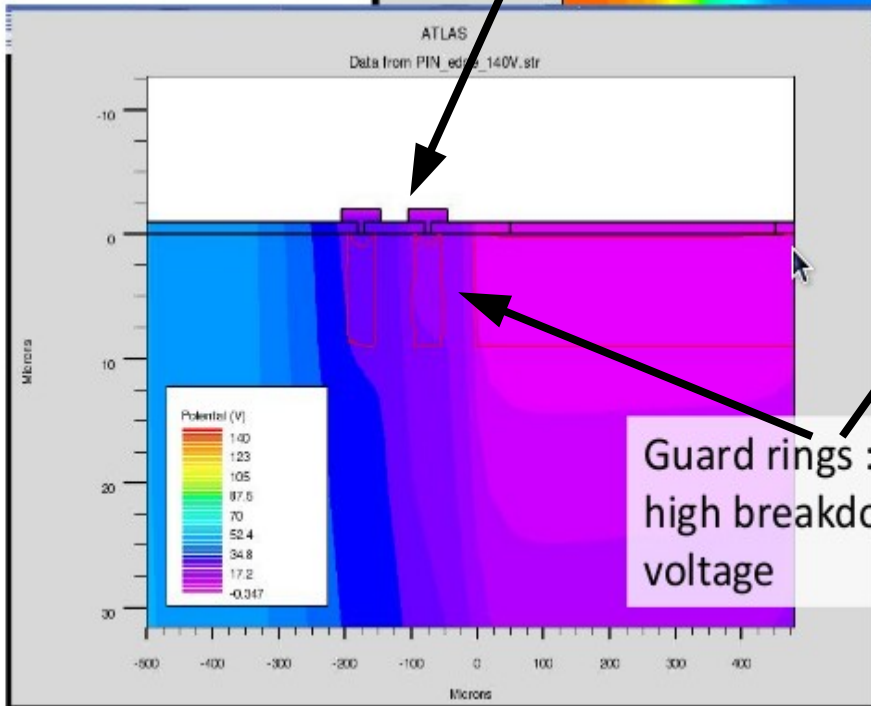
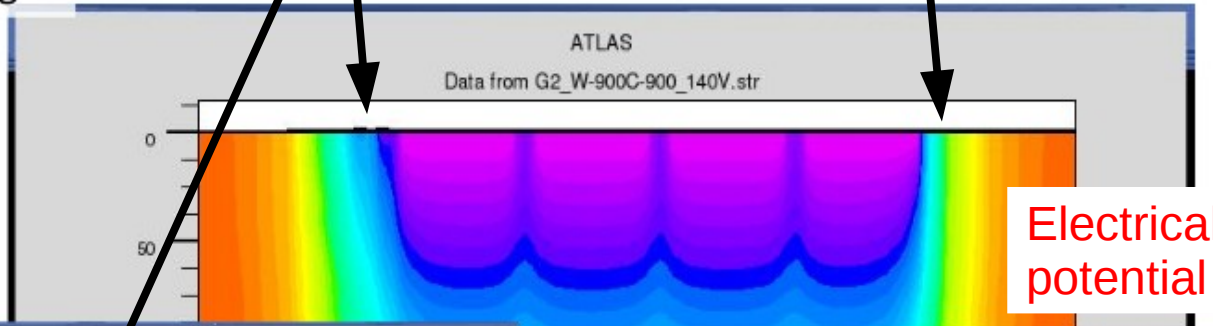


Simulations of guard rings etc.

4 pixels (500 um),
500 or 700 um edges

Edge with
guard ring

Edge without
guard ring



DIF: Status (generic) and Plans

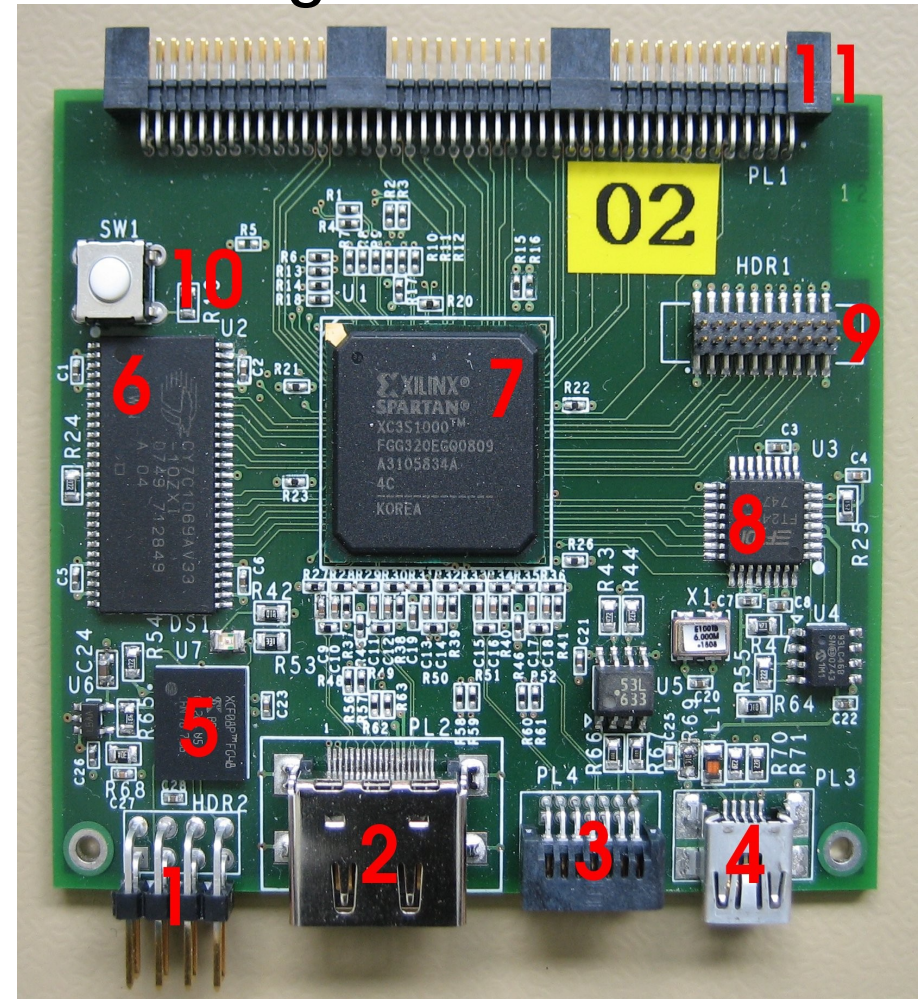


e.g: ECAL DIF

- Test hardware in place
- Firmware development started
 - LDA Link integration

ECAL DIF prototype: 65x72mm, 8 layers

1. JTAG programming header
2. LDA link HDMI connector
3. DIF link connector
4. mini-USB connector
5. Xilinx PROM
6. Cypress 2MB 10ns SRAM
7. Xilinx Spartan3-1000 FPGA
8. FDTI FT245R USB controller
9. 20p user header connector
10. reset pushbutton
11. 90pin SAMTEC IB connector



- 2 DIFs produced, parts available for 10 more.
- DIF hardware is (at least partly) functional